Notice of References Cited	Application/Control No. 10/678,184	Applicant(s)/Patent Under Reexamination SHIN ET AL.	
	Examiner Fernando L. Toledo	Art Unit 2823	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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NON-PATENT DOCUMENTS

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	U	Wolf and Tauber; Silicon Processing for the VLSI Era Volume 1: Process Technology; page 335; Lattice Press, 1986; Sunset Beach, CA
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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